

METHOD FOR FORMING A DEEP TRENCH CAPACITOR BURIED PLATE

Appl. No. : 10/605,234 Confirmation No. 3393
Applicant : Chih-Han Chang,
Hsin-Jung Ho,
Chang-Rong Wu,
Chien-Jung Sun
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TC/A.U. : 2823
Examiner : Nguyen, Khiem D
Docket No. : NTCP0004USA
Customer No. : 27765

Commissioner for Patents
P.O. Box 1450
Alexandria VA 22313-1450

AMENDMENT

Sir:

- 5 In response to the Office action of October 23, 2006, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.